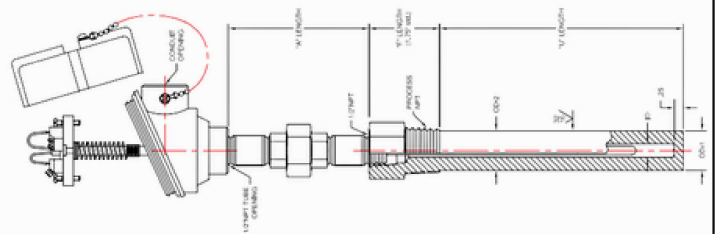
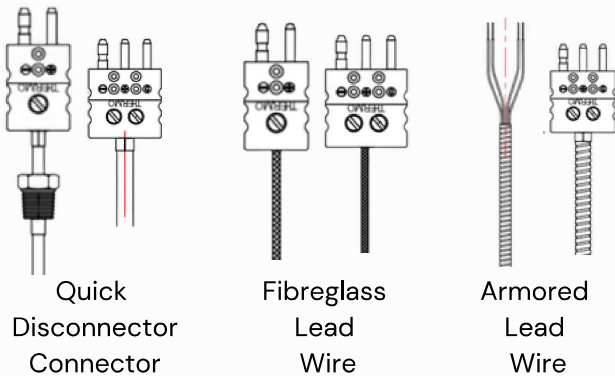


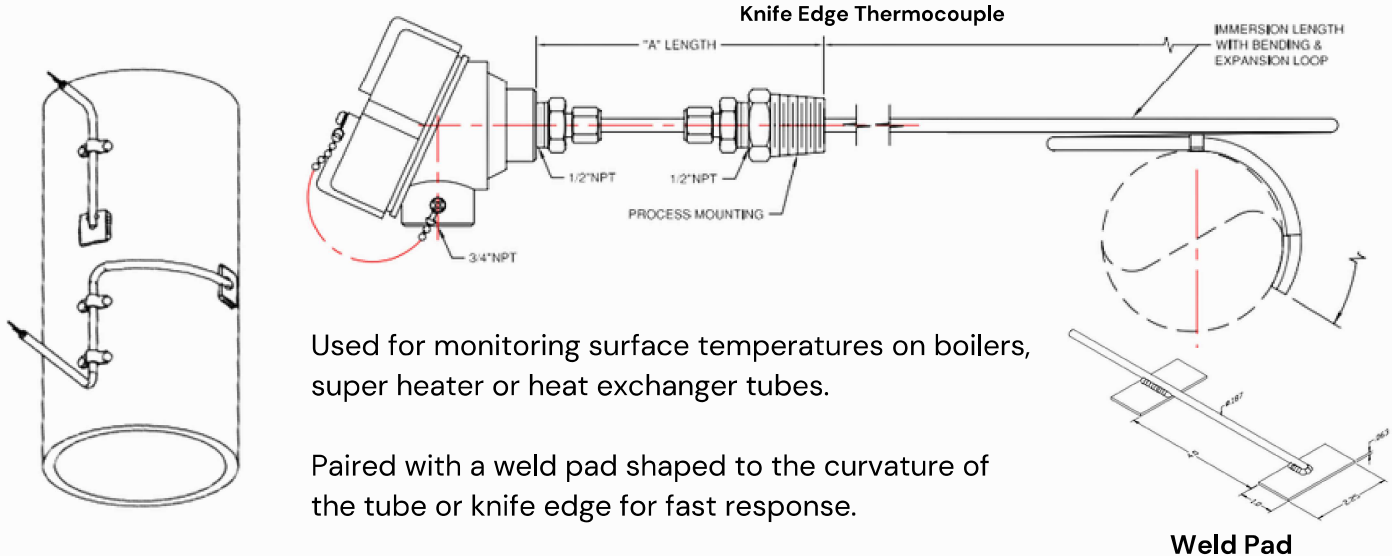
RTD & THERMOCOUPLE

IMMERSION

INDUSTRIAL

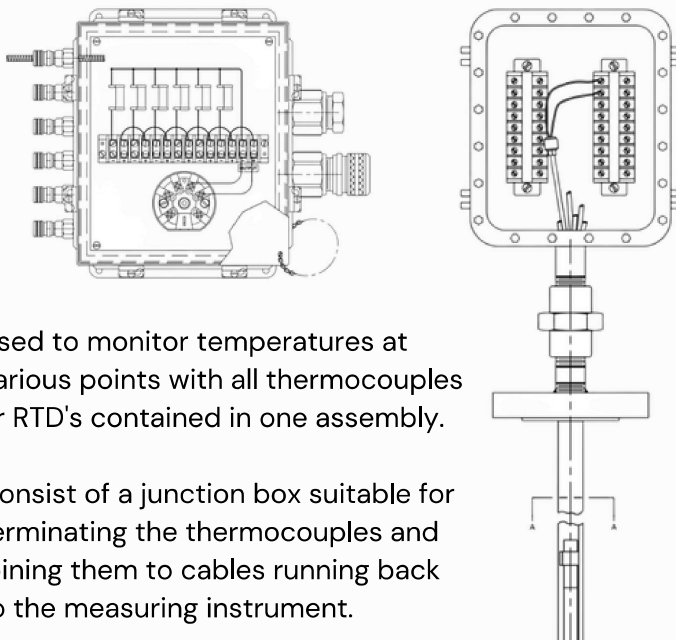


TUBE SKIN THERMOCOUPLE



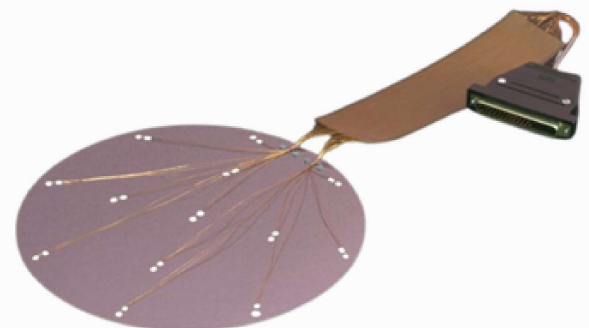
MULTICOUPLE

WAFER SENSORS



Used to monitor temperatures at various points with all thermocouples or RTD's contained in one assembly.

Consist of a junction box suitable for terminating the thermocouples and joining them to cables running back to the measuring instrument.



The Instrumented Wafer (Thermocouples, Bonded Wafer or RTDs) finds application in semiconductor processing equipment where knowing and controlling the temperature at the surface of a wafer is critical.